

# Analysis of Layout Arrangement for CMOS Oscillators to Reduce Overall Variation on Wafer

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**Abstract**—This investigation demonstrates the analysis of various layout arrangements for oscillators (OSC) realized by CMOS technologies. More importantly, the analysis shows that the serpentine style of OSC stages (tiles) attains the minimum variation on wafer. Based on the analytic solution, various OSCs realized using 0.18  $\mu\text{m}$  CMOS process, where the chip area of  $1.458 \times 0.908 \text{ mm}^2$ , are simulated to justify the robustness of the proposed layout arrangement.

**Keywords**— oscillator, serpentine style, variation minimization, CMOS, on wafer

## I. Introduction

Thanks to the advancement of CMOS semiconductor technologies, transistors as well as devices are downsized rapidly and constantly. The continuous shrinkage of nanometer processes, e.g., from 180 nm, 90 nm, ..., 16 nm, manufacturing variations on wafer become serious threat to the functionality of devices. The reason is no matter what process is used, it is suffered from various environmental factors, e.g., temperature, vibration, power surge, etc. OSC is one of the major components of digital circuits, which is usually the clock generator. This works manages to explore what kind of layout arrangement of OSCs with many identical delay stages will attains the best resistance to the variations caused by manufacturing on wafers.

## II. Layout Anslsis of Oscillators

Fig. 1 shows a typical differential OSC, consisting of 16 delay stages, 2 16-to-1 MUXs, a Driving Buffer, and a Decoder to select a number of active stages such that the frequency is determined. Typical process variation on wafer are usually caused by the non-uniform doping concentrations of chemical substances. Thus, various layout styles will have difference resistance to these on-wafer variations. Assuming that the variation at the origin  $A(0,0)$ ,  $P_A(0,0)$ , has the fixed variation “c”. We then assume the variation amount along the x axis for each beffer stage is “a”, and that along the y axis is “b”. In other words, the variation is assumed to be a linear function

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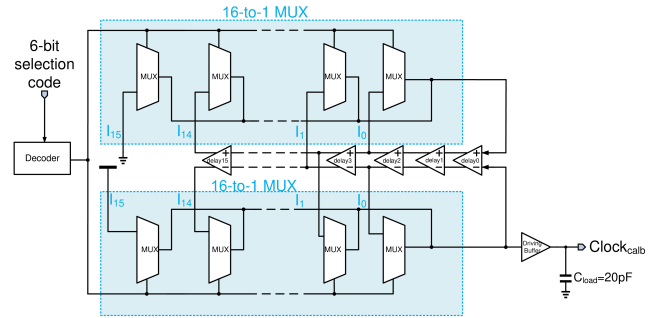


Fig. 1. An illustrative OSC with 16 delay stages.

against distance. For example, delay stage  $B(i,j)$  has the variation  $P_B(i,j)$  as follows.

$$P_B(i,j) = a \times i + b \times j + c \quad (1)$$

- straight line layout : As shown in Fig. 2, the total variation  $P_{\text{total1}}(i,j)$  is:

$$\sum_{i=1}^{16} \sum_{j=1}^{16} P_{\text{total1}}(i,j) = \sum_{i=1}^{16} \sum_{j=1}^{16} (a \cdot i + b \cdot j + c) \quad (2)$$

$$= 136a + 16b + 16c$$

The average of the variation  $P_{\text{totalaverage1}}(i,j)$  in this case is:

$$P_{\text{totalaverage1}}(i,j) = 8.5a + b + c \quad (3)$$

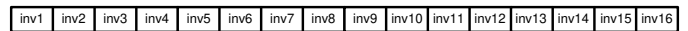


Fig. 2. Straight line layout style of OSC.

- serpentine layout : Referring to Fig. 3, the total variation  $P_{\text{total2}}(i,j)$  in this case is:

$$\sum_{i=1}^4 \sum_{j=1}^4 P_{\text{total2}}(i,j) = \sum_{i=1}^4 \sum_{j=1}^4 (a \times i + b \times j + c) \quad (4)$$

$$= 40a + 40b + 16c$$

Then, the average of the variation  $P_{\text{totalaverage2}}(i, j)$  is:

$$P_{\text{totalaverage2}}(i, j) = 2.5a + 2.5b + c \quad (5)$$

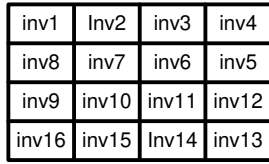


Fig. 3. Serpentine layout style of OSC.

Based on Eqn. (2) and (4), we have the following observation.

$$\begin{aligned} P_{\text{total1}}(i, j) &\geq P_{\text{total2}}(i, j) \\ \Rightarrow 136a + 16b + 16c &\geq 40a + 40b + 16c \quad (6) \\ \Rightarrow 4a &\geq b \end{aligned}$$

Namely, the variation of the serpentine style is better than that of the straightline style as long as “a” is more than or equal to 1/4 of “b”.

### III. Simulation and Discussion

The proposed OSCs are realized on silicon using TSMC 0.18  $\mu\text{m}$  CMOS process, as shown in Fig. 4. Because of area limitation, the chip only comprises the serpentine style layout and straight line layout. The chip size is  $1.458 \times 0.908 \text{ mm}^2$ , and the core area is  $989 \times 344 \mu\text{m}^2$ .

Fig. 5 shows the many more various buffer stage arrange-

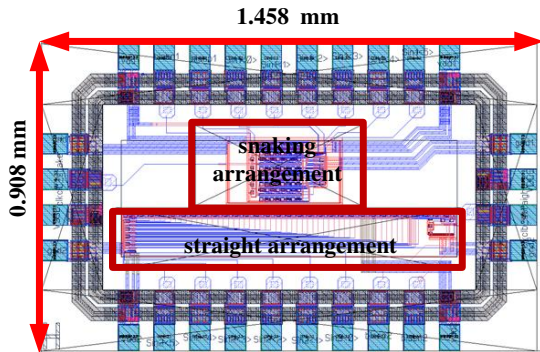


Fig. 4. Layout of various OSCs.

ments and their corresponding post-layout simulations of generated clock frequencies. The pre-layout simulation of the OSC is aimed at 490 MHz, which ignores the on-wafer variations. The post-layout simulation of the serpentine style layout (D in Fig. 5) shows the frequency nearest to that generated in the pre-layout simulation.

Table I tabulates the performance comparison of the proposed design and several recent patents regarding layout styles.

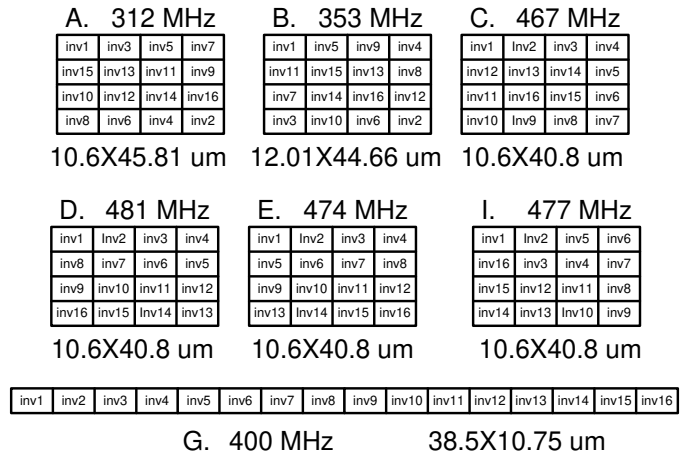


Fig. 5. Various arrangements and the clock rates of OSC by post-layout simulations.

TABLE I  
Comparison with Prior Patents.

	[1]	[2]	[3]	this work
Year	2006	2012	2015	2021
Layout arrangement	straight	straight	serpentine	serpentine
Variation analysis	N/A	N/A	N/A	Yes

### IV. Conclusion

This investigation presents an analytic and robust method to explore the best layout style for OSCs to resist the on-wafer variation. Moreover, the proposed serpentine layout style can be applied in other CMOS technology nodes to make the chip performance more predictable in the early design phase.

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